



8/ Response (X-E)
T. Steptoe
9/11/03

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2863
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64673

Teruji IKEMATSU

Appln. No.: 09/917,880

Group Art Unit: 2863

Confirmation No.: 2071

Examiner: Michael P. Nghiem

Filed: July 31, 2001

For: METHOD FOR CONTROLLING EXPOSURE AND SCAN-EXPOSURE APPARATUS

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 28, 2003, please consider the remarks as submitted herewith on the accompanying pages.

REMARKS

This Response, submitted in reply to the Office Action dated April 28, 2003, is believed to be fully responsive to each point of rejection raised therein. Accordingly, favorable reconsideration on the merits is respectfully requested.

Claims 1-19 remain pending in the application. There are no prior art rejections of the claims. However, the claims remain rejected under 35 U.S.C. § 112, first paragraph, for

PLS En 9/17/03
Am

RECEIVED
SEP - 3 2003
TECHNOLOGY CENTER 2800